

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| In re Patent Application of: |) | Confirmation No.: 1187 |
| Koichiro TANAKA et al. |) | Examiner: Sang Yeop Paik |
| Serial No. 10/579,238 |) | Group Art Unit: 3742 |
| Filed: May 12, 2006 |) | |
| For: LASER IRRADIATION APPARATUS |) | |
| AND LASER IRRADIATION METHOD |) | |

AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated May 23, 2011, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 8 of this paper.